

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Maher et al.
App. No : 10/771,283
Filed : February 2, 2004
For : HIGH THROUGHPUT METHOD AND
SYSTEM FOR SCREENING
CANDIDATE COMPOUNDS FOR
ACTIVITY AGAINST TARGET ION
CHANNELS
Examiner : S. E. Fernandez
Art Unit : 1651
Conf No. : 9653

RESPONSE WITH REQUEST FOR CONTINUED EXAMINATION

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Together with a Request for Continued Examination and in response to the Final Office Action of November 17, 2008 Applicant submits the following: